

**EXPRESS MAIL NO. EV371410951US**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No: **EXPRESS MAIL NO. EV371410951US**  
Filing Date: **Filed herewith**  
Applicant: **Frank M. Cerio, Jr. et al.**  
Title: **IONIZED PHYSICAL VAPOR DEPOSITION (iPVD) PROCESS**  
Atty Docket: **TAZ-259**

MS Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INFORMATION DISCLOSURE STATEMENT**

In accordance with the duty of candor and good faith imposed by 37 CFR §1.56 and means of complying therewith according to 37 CFR §§1.97 and 1.98, the references listed on the attached PTO-1449 are called to the attention of the United States Patent and Trademark Office in connection with the above-identified patent application.

This application was filed after June 30, 2003, and therefore, no copies are enclosed of the U.S. Patents or Published applications cited as references herein.

No admission is made that the cited art represents the prior art or that the cited art is the most material art. Applicant submits that none of the cited references alone or in combination disclose or render obvious the subject matter in the present invention. The Examiner is urged to consider the cited references and to make an independent decision with respect to their materiality.

Respectfully submitted,

WOOD, HERRON & EVANS, L.L.P.

By 

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SUBSTITUTE FORM PTO-1449 (MODIFIED)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. TAZ-259		SERIAL NO. EXPRESS MAIL NO. EV371410951US	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT  (37 CFR 1.98(b))				APPLICANT Cerio, Jr., et al.		FILING DATE Filed Herewith	
(Use several sheets if necessary)				GROUP			

  

U.S. PATENT DOCUMENTS													
EXAMINER INITIAL		PATENT NUMBER							ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A.A	6	2	8	7	4	3	5	09/2001	Drewery et al.			
	A.B												
	A.C												
	A.D												
	A.E												
	A.F												
	A.G												
	A.H												
	A.I												
	A.J												
	A.K												

  

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS							
	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION (YES/NO)	
	A.L						
	A.M						
	A.N						
	A.O						
	A.P						
	A.Q						

  

OTHER DOCUMENTS (Including Author, Title, Date, Place of Publication)		
	A.R	Yasar et al., <u>Patent Application Publication No. US 2003/O034244 A1</u> , Pub. Date February 20, 2003
	A.S	
	A.T	

  

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not in conformance. Draw line through citation only if not in conformance and not considered. Include a copy of this form with next communication to applicant.